

 Sughrue

SUGHRUE MION, PLLC

January 28, 2004

**MAIL STOP PATENT APPLICATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Re: Application of Yoshihiko UCHIDA and Kenji NAKAMURA  
ORGANIC SEMICONDUCTOR ELEMENT AND FABRICATION METHOD  
THEREOF  
Assignee: **PIONEER CORPORATION**  
Our Ref. Q79569

Dear Sir:

Attached hereto is the application identified above comprising sixteen (16) sheets of the specification, including the claims and abstract and three (3) sheets of drawings. **The requisite U.S. Government Filing Fee, copies of the executed Declaration and Power of Attorney and Assignment will be submitted at a later date.**

The Government filing fee is calculated as follows:

Total claims	<u>14</u>	-	<u>20</u>	=	<u>          </u>	x	\$18.00	=	<u>          </u>	\$0.00
Independent claims	<u>2</u>	-	<u>3</u>	=	<u>          </u>	x	\$86.00	=	<u>          </u>	\$0.00
Base Fee										\$770.00
<b>TOTAL FEE</b>										<b>\$770.00</b>

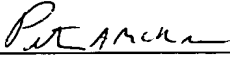
Priority is claimed from:

<u>Country</u>	<u>Application No</u>	<u>Filing Date</u>
Japan	2003-19995	January 29, 2003

The priority document is submitted herewith.

Respectfully submitted,  
SUGHRUE MION, PLLC

Attorneys for Applicant

By:  Darryl Mexic  
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WASHINGTON OFFICE

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CUSTOMER NUMBER

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